

**Course Schedule, group M15-307****MONDAY**

09:20 — 11:00	■ LEC	Elect	Planar Cycle Technology (2017-02-06 — 2017-03-13) 🎓 Kozyrev A.A. 📍 FIAN
	■ SEM	Elect	Planar Cycle Technology (2017-03-20 — 2017-04-10) 🎓 Kozyrev A.A. 📍 FIAN
11:55 — 13:30	■ SEM	Elect	Planar Cycle Technology 🎓 Kozyrev A.A. 📍 FIAN
14:30 — 16:05	■ LEC		Methodology of Science (2017-02-06 — 2017-03-13) 🎓 Arshinov V.I. 📍 404

**TUESDAY**

08:30 — 10:05	■ LEC	Opt	Military Training (2017-02-07 — 2017-05-16) 📍 dep.20
10:15 — 16:05	■ SEM	Opt	Military Training (2017-02-07 — 2017-05-16) 📍 dep.20

**WEDNESDAY**

11:05 — 12:40	■ SEM		Practical Training (Research Work) 🎓 Kanavin A.P., Cheshev E.A., Popov Y.M., Krohin O.N., Zaslavitskiy I.I., Bezotosnyy V.V., Aleschenko Y.A., Zvestovskaya I.N. 📍 FIAN
14:30 — 16:05	■ LEC	Elect	Modern Optics (2017-02-08 — 2017-03-15) 🎓 Kulchin Y.N. 📍 98-8
	■ SEM	Elect	Modern Optics (2017-03-22 — 2017-04-12) 🎓 Kulchin Y.N. 📍 98-8
16:15 — 17:50	■ SEM	Elect	Modern Optics 🎓 Kulchin Y.N. 📍 98-8

**THURSDAY**

08:30 — 10:05	■ LEC		Management of Intellectual Property (2017-02-09 — 2017-04-20) 🎓 Yushkov E.S. 📍 T-209
	■ SEM		Management of Intellectual Property (2017-02-16 — 2017-04-27) 🎓 Yushkov E.S. 📍 T-209
10:15 — 11:50	■ LAB		Latex Basics (2017-02-09 — 2017-03-30) 🎓 Kuznetsov A.V. 📍 K-1102
11:55 — 13:30	■ LAB		Latex Basics (2017-02-16 — 2017-03-30) 🎓 Kuznetsov A.V. 📍 K-1102
12:45 — 14:20	■ SEM		Methodology of Science (2017-02-09 — 2017-04-20) 🎓 Martinkus P.P. 📍 V-403

**FRIDAY**

10:15 — 13:30	■ SEM	Elect	Modern Laser Technologies 🎓 Fronya A.A. 📍 FIAN
---------------	-------	-------	--

**SATURDAY**

10:15 — 11:50	■ LEC	Elect	Physics and Technology of Semiconductor Lasers (2017-02-11 — 2017-03-18) 🎓 Mikaelyan G.T. 📍 MPK-355
	■ SEM	Elect	Physics and Technology of Semiconductor Lasers (2017-03-25 — 2017-04-15) 🎓 Mikaelyan G.T. 📍 MPK-355
11:55 — 13:30	■ SEM	Elect	Physics and Technology of Semiconductor Lasers 🎓 Mikaelyan G.T. 📍 MPK-355